Rate capability and magnetic field tolerance measurements of fast timing microchannel plate photodetectors

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Abstract

Microchannel plate photodetectors provide both picosecond time resolution and sub-millimeter position resolution, they are attractive sensors for particle identification detectors of future US Electron Ion Collider. We have tested the rate capability and magnetic field tolerance of 6×6 cm² microchannel plate photodetectors fabricated at Argonne National Laboratory. The microchannel plate photodetector is designed of low-cost all-glass vacuum package with a chevron pair stack of "next generation" microchannel plates functionalized by atomic layer deposition. The rate capability test was performed using Fermilab 120 GeV primary proton beam, and the magnetic field tolerance test was performed using a solenoid magnetic with tunable magnetic field strength up to 4 Tesla. The measured gain of the microchannel plate photodetector is stable up to 75 kHz/cm², and varies depending on the applied magnetic field strength and the rotation angle relative to the magnetic field direction.

Index terms— Fast timing, Microchannel plate, Pho- 32 todetector, Electron Ion Collider, Particle identification 33 detector, Rate capability, Magnetic field, Rotation angle. 34

1. Introduction

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The world's first Electron Ion Collider (EIC) [1] has 38 been recommended as the highest priority for a new fa-39 cility construction in the U.S [2]. This unique facility 40 will explore several features of the strong force and QCD 41 through mapping the partons, quarks and gluons, content 42 of nucleons and nuclei up to uranium. Several detector 43 concepts are proposed and designed for the EIC at Ar- 44 gonne National Laboratory (ANL), Brookhaven National 45 Laboratory (BNL), Thomas Jefferson National Accelera- 46 tor Facility (JLab) and some other institutes, with slightly 47 different layout. For all these EIC detector designs, excel-48 lent particle identification (PID), $(e/\pi/K/p)$ separations 49 over a wide range of momentum, is essential for the pro- 50 posed measurements, such as semi-inclusive deep inelastic 51 scattering and exclusive deeply virtual Compton scatter- 52 ing. Time-of-flight systems and imaging Čerenkov detec-53 tors (RICH, DIRC) [3, 4, 5] are proposed and studied, ⁵⁴ calling for large area, low cost photon sensors with high 55 spatial resolution, high rate capability, radiation tolerance, ⁵⁶ magnetic field tolerance and picosecond timing resolution. 57

Microchannel plate (MCP) photodetectors are com- 58 pact photon sensors, usually with an internal chevron pair 59 stack of MCPs, providing both high spatial and temporal 60 resolution in a vacuum package. The Large Area Picosec- 61 ond Photodetector (LAPPD TM) is the world largest MCP 62 based photodetector with an active area of 20×20 cm² [6]. 63 It is designed of a modular all-glass detector package with 64

the "next generation" MCPs produced by applying resistive and emissive coatings to borosilicate glass capillary array (GCA) substrates through atomic layer deposition (ALD) process. The all-glass design and low-cost "next generation" MCPs provide great advantages to reduce the $LAPPD^{TM}$ product cost per area compared to other MCP based photodetectors currently available. As a collaborator of the LAPPD project [7], we have built a MCP photodetector fabrication system [8] at Argonne National Laboratory to fabricate 6×6 cm² MCP photodetectors with LAPPD design. The fabricated MCP photodetectors were provided to several experiments for early test and adaption of LAPPD detector. The MCP photodetector fabrication system also serves as a R&D platform for LAPPD package design validation and optimization. Several 6×6 cm² MCP photodetectors with standard LAPPD design were successfully fabricated and tested [9, 10, 11], exhibiting high gain over 10⁷, overall time resolution of 35 ps and position resolution better than 1 mm. The excellent performance of these 6×6 cm² MCP photodetectors shows that the low-cost LAPPD TM detector is a promising candidate for EIC PID photo sensors. Performance tests of the MCP photodetectors in high rate, high radiation damage and high magnetic field environments are required to further validate the application of LAPPD TM detectors as EIC PID photo sensors.

In this paper, we describe the current design of 6×6 cm² MCP photodetectors fabricated at Argonne National Laboratory, report recent results on the performance tests of these 6×6 cm² MCP photodetectors in high rate environment and high magnetic field environment. The direction on further optimization of the LAPPDTM design for EIC PID application is also addressed at the end of this paper.

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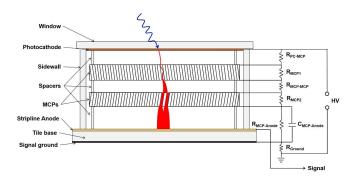


Figure 1: Schematic of MCP-based photodetector assembly (not to scale) and the electrical circuit diagram. External connections to the top and bottom surfaces of the two MCPs are through ultrathin metal shims (not shown) to special extra strip lines on the tile base. The circuit diagram shows connections through side wall in a simplified format.

2. Design of the MCP-based photodetector assem₁₀₅ bly

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Current design of the 6×6 cm² MCP photodetector¹⁰⁷ is developed from the original LAPPD internal resistor¹⁰⁸ chain design [11], similar to the current standard design of commercial LAPPDTM detectors [12]. Figure 1 shows¹¹⁰ a schematic design (not to scale) of current MCP-based¹¹¹ photodetector assembly and the electrical circuit diagram.¹¹²

The MCP photodetector is an all glass body assembly, 113 consists of glass base window, top window, side wall, three 114 grid spacers and two MCPs. The sidewall is frit bonded 115 onto the base window, with silver stripline anodes printed, 116 leading the signals and high voltage connections to outside. 117 Grid spacers are placed between anode and MCPs and top 118 window as insulators to separate these components, they also hold these internal components in place in the vac-119 uum assembly. Four ultra-thin metal shims are applied at the top and bottom surfaces of the two MCPs to lead the 120 electrical connection to external connections, detailed cir-121 cuit connection inside the vacuum package is described in 122 reference [13]. This independent bias-voltage design pro-123 vides advantage of individually controlling and fine tuning 124 of the bias voltage for each MCP. Bialkali photocathode¹²⁵ is deposited on the inside surface of the top window, and 126 an indium seal is made between the top window and the 127 sidewall through a low temperature thermo-compression¹²⁸ sealing process to form a hermetic vacuum detector pack-129 age. The completed MCP-based photodetector is attached 130 to a custom-made circuit board, providing a permanent¹³¹ mount and firm electrical connections as shown in Figure¹³² 2. External electrical connections for both signal and high¹³³ voltage are inserted into the external resistor connections¹³⁴ to serve as high voltage divider, ensuring both MCPs work¹³⁵ at an independently optimized high voltage for best per-136 formance. Additional capacitors may also be added across¹³⁷ the resistor divider for better signal waveform.

The microchannel plates used in the 6×6 cm² MCP¹³⁹ photodetector are diced from the "next generation" large¹⁴⁰

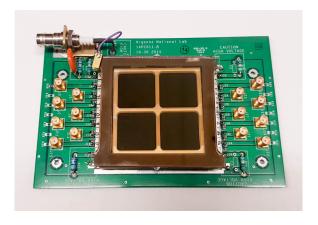


Figure 2: Completed MCP-based photodetector attached to a circuit board, providing firm electrical connections.

area $(20\times20~{\rm cm}^2)$ MCPs [6, 12], the world largest commercially available MCPs. These "next generation" MCPs are produced through a glass drawing process and functionalized through atomic layer deposition, completely different from the production of traditional leaded glass MCPs. The glass drawing process uses borosilicate glass as tube materials, which is considerably less expensive than the leaded glass and eliminates the chemical etching process required in traditional method, making it much more cost-effective for MCP production. Here, we use standard borosilicate glass MCPs with 20 μ m pore size, 60:1 L/d (pore length to diameter) ratio and 80 bias angle relative to the MCP surface normal. The two MCPs are placed as the "chevron" configuration in the vacuum package, which reversed the bias angle to -8°.

3. Rate capability measurement

The rate capability of MCP-based photodetectors is one of the most critical parameters for applications in high luminosity environment, such as EIC. Due to the high resistive layer coating on ALD functionalized MCPs, the current in the MCP pores may not flow off fast enough when the MCP-based detector is exposed to high particle rates. This effect may cause severe charge saturation, reduce the gain of the MCP-based photodetector and limit the detector performance.

We investigated the rate capability of the $6\times 6~\rm cm^2$ MCP-based photodetectors with 120 GeV/c primary proton beam at the Fermilab Test Beam Facility (FTBF). The beam was delivered as a slow spill with a 4 s duration once per minute with a maximum intensity of 10^5 particles per spill. The beam shape is circular with a diameter of 6 mm and a gaussian density profile. The beam intensity was close to a constant during each spill period. On the beamline, the 120 GeV/c incident proton beam was monitored by an upstream multiwire proportional counter to see the beam profile. Three plastic scintillators in coincidence were used as a trigger and to count the number of incident proton. A light-tight dark box was designed

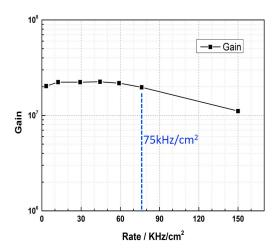


Figure 3: Gain of MCP-based photodetector as a function of the $120~{\rm GeV/c}$ proton beam flux. The gain of the detector is stable up to beam flux of $75~{\rm kHz/cm^2}$, and the gain is still over 10^7 at $150~{\rm kHz/cm^2}$.

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to hold the MCP-based photodetector in the beam path¹⁷⁶ with the detector surface facing the beam direction. High¹⁷⁷ voltage was applied to the MCPs through external resistor¹⁷⁸ voltage divider, and signals from the strip lines were read-¹⁷⁹ out through the DT5742 desktop digitizer [14] produced¹⁸⁰ by CAEN (Costruzioni Apparecchiature Elettroniche Nu-¹⁸¹ cleari S.p.A.) with a sampling rate of 5 GS/s. The digitizer¹⁸² is based on the switched capacitor array DRS4 (Domino¹⁸³ Ring Sampler) chip [15] and have 16 analog input channels¹⁸⁴ and 1 additional analog input for fast trigger.

During our experiment, the 120 GeV/c proton beam¹⁸⁶ intensity was tuned to vary from 500 to 40,000 particles¹⁸⁷ per spill. The beam rate was calculated using the num-¹⁸⁸ ber of triggers per spill and was corrected for the size of¹⁸⁹ the beam spot by reconstructing the beam profile. The¹⁹⁰ calculated beam rate varies from 3 to 150 kHz/cm² corre-¹⁹¹ sponding to the monitored beam particle intensity. Figure¹⁹² ?? shows the gain of the MCP-based photodetector mea-¹⁹³ sured as a function of the beam rate. The measured gain of¹⁹⁴ the investigated detector is stable up to a beam flux of 75¹⁹⁵ kHz/cm² and still over 10⁷ when the beam flux reaches 150¹⁹⁶ kHz/cm². Such a high rate capability of the MCP-based¹⁹⁷ photodetector will be sufficient for EIC PID detectors at the proposed energies of the beams.

4. Magnetic field tolerance measurement

In the EIC detectors, solenoid magnet with field strengt $m fl^2$ of 1.5 Tesla are proposed. The imaging Čerenkov detec- 203 tors (RICH, DIRC) and time-of-flight systems are designed to cover the area of the barrel and end caps for charged par- 205 ticle $(\pi/K/p)$ separations. This compact design requires the photo sensors working properly in a harsh environment with magnetic field strength up to 1.5 Tesla.

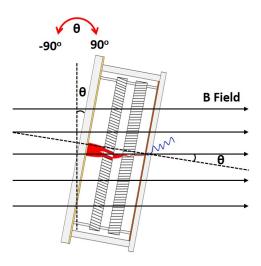


Figure 4: Schematic of the rotation of MCP-based photodetector with angle θ relative to the magnetic field direction during the measurement.

At Argonne National Laboratory, a decommissioned superconducting magnet from a magnetic resonance imaging (MRI) scanner was acquired to test instruments for the muon g-2 experiment [16]. The magnet provides a large bore with a diameter of 68 cm and a very homogenous field (7 ppb/cm), the magnitude of the magnetic field is tunable up to 4 Tesla. We have built a characterization system compatible with the solenoid magnet to test the performance of the 6×6 cm² MCP-based photodetector in strong magnetic field environment. The MCP photodetector was fixed in a custom built non-magnetic, light-tight dark box. The dark box was held on a test platform with the detector surface normal to the direction of magnetic field. The position of the dark box was adjusted so that the center of the MCP photodetector is well aligned with the center of the solenoid magnet. A rotation mechanism was also integrated with the system, allowing rotation of the MCP-based photodetector with angle θ as shown in Figure 4 (not to scale). A 405 nm light-emitting diode (LED) was used as the light source and introduced to the surface of the MCP photodetector through an optical fiber. High voltage was applied to the MCPs from a supply with variable voltage control, and signals from the strip lines were readout through CAEN DT5742 desktop digitizer.

4.1. Magnetic field strength dependence

The dependence of the MCP photodetector performance on the magnetic field strength was done at rotation angle $\theta=0^{\circ}$, i.e., the direction of the magnetic field is normal to the surface of the MCP-based photodetector. We measured the gain of the investigated MCP photodetector in various magnetic field environment with different bias voltages, the results are plotted in Figure 5. The gain is calculated based on integrated charge in pulse normalized to single photoelectron. At a fixed bias high voltage, the gain of MCP photodetector increases slightly as the

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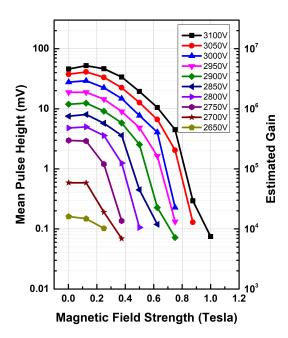


Figure 5: Dependence of the MCP-based photodetector gain on the 240 magnetic field strength at different bias voltages.

magnetic field strength increases to 0.2 T, and starts to de- 243 crease as the magnetic field strength continues to increase, 244 and eventually breaks down at magnetic field strength of 245 ~ 0.8 T. In the same magnetic field environment, the gain 246 of the MCP photodetector increases as the biased high 247 voltage increases. This behavior is similar to our previous 248 measurement of the MCP photodetectors without apply- 249 ing magnetic field.

4.2. Magnetic field angle dependence

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The performance of MCP-based photodetector at dif- $^{253}\,$ ferent angle was also studied by rotating the MCP pho-254 to detector along with angle θ relative to the magnetic field 255 direction, as shown in Figure 5. We fixed the biased high 256 voltage at 3000 V on the photodetector and rotated the 257 photodetector from -90° to 90° for a full angle measure- 258 ment. Figure 6 shows the gain of MCP photodetector 259 measured as a function of the rotation angle θ at magnetic field strength of 0.5 and 0.25 Tesla respectively. The MCP₂₆₀ photodetector almost does not provide detectable signals when $\theta \leq -30^{\circ}$ or $\theta \geq 30^{\circ}$. Within - $30^{\circ} \leq \theta \leq 30^{\circ}$, ²⁶¹ there are two gain peaks at $\theta = \pm 8^{\circ}$, which are due to²⁶² the "chevron" configuration of two MCPs inside the pho-263 todetector. The gain reaches a maximum when the pore²⁶⁴ of either MCP is well aligned with the magnetic field di-265 rection. Meanwhile, the intensities of the two peaks are²⁶⁶ different, which is due to the different effect from the top²⁶⁷ and bottom MCPs.

4.3. Design optimization of MCP-based photodetector

In EIC experiment, 1.5 Tesla solenoid magnet will be 271 used for tracking charged particles. The magnetic field 272

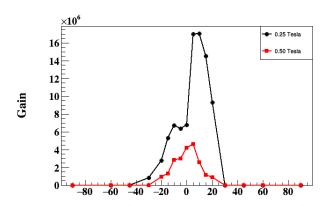


Figure 6: Gain of MCP-based photodetector as a function of rotation angle *theta* relative to the direction of magnetic field. The two peaks around -8° and 8° indicates the effect due to the 8° bias angle of the MCPs. Note that the intensities of these two peaks are not the same due to the different effect from top and bottom MCPs.

tolerance requirement varies from detector to detector depending on their distance and direction to the magnet, and is up to 1.5 Tesla. From our measurement, the 6×6 cm² MCP-based photodetector has shown a good magnetic field tolerance up to 0.8 Tesla, comparable to that of current commercially available MCP-PMTs ($\sim 1.0 \text{ T}$) with similar pore size [17]. Here, we must emphasize that the current LAPPD design is not optimized yet for magnetic field tolerant applications. The distances between the photocathode, MCPs and anode are pretty large in the LAPPD design, e.g., spacings between the photocathode and MCPs are 2 mm and the spacing between the MCP and anode is 3.2 mm [10], these distances should be reduced to minimize the electron transit distance. Meanwhile, MCP photodetectors with smaller pore size MCPs have shown better magnetic field tolerance than the ones with larger pore size MCPs [17, 18, 19]. A redesign of the current LAPPD configuration with smaller pore size (e.g. 10 μm or even $5 \mu m$) "next generation" MCPs and reduced distances between the PMT elements would further improve its magnetic field tolerance to the required level.

5. Conclusions

We have described the current design of 6×6 cm² microchannel plate photodetectors with "next generation" MCPs functionalized through atomic layer deposition process. The rate capability and magnetic field tolerance of these photodetectors were tested at Fermilab 120 GeV proton beam and Argonne 4 Tesla magnetic field facility respectively. The photodetectors exhibit stable performance up to 75 kHz/cm² and magnetic field tolerance up to 0.8 Tesla. The magnetic field angle dependence was also measured, showing enhanced performance at $\pm 8^{\circ}$ tilt angle due to the original MCP 8° bias angle. The magnetic field tolerance of these detectors should be further improved by

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applying smaller pore size MCPs and redesign the package₃₃₁ with reduced distances between the photocathode, MCPs³³² and anode.

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6. Acknowledgments

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